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\*\* CONTINUING DATA \*\*\*\*\* *TN*

\*\* FOREIGN APPLICATIONS \*\*\*\*\* *TN*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED  
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Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY CA	SHEETS DRAWING 8	TOTAL CLAIMS 31	INDEPENDENT CLAIMS 5
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Verified and Acknowledged

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TITLE  
 Methods of reducing plasma-induced damage for advanced plasma CVD dielectrics

☐ All Fees